

IN THE CLAIMS:

Please amend the claims as follows.

1. (Currently Amended) A capacitance type sensor comprising:

 a detective member[[],] configured to detect an external force applied thereto;

 a first electrode being opposite to facing the detective member,

 a second electrode arranged-disposed between the detective member and the first electrode and constituting such that a capacitance element[[s]] is formed by
 with the first electrode and the second electrode, the second electrode being
 displaceable in a same direction as-of displacement of the detective member
 when the detective member is displaced, and

 a flexible board substrate having flexibility on which the first electrode and the second electrode are both arranged-disposed, the flexible board being folded such that the first electrode and the second electrode face each other,
 wherein the capacitance type sensor is capable of recognizing identifies the displacement of the detective member on the basis of a detection, using a signal input to the first electrode, of a change in capacitance value of the capacitance element caused by a change in distance between the first electrode and the second electrode.

2. (Currently Amended) The capacitance type sensor according to claim 1, wherein the first electrode and the second electrode are both arranged-disposed on one side of the substrate-flexible board.

3. (Currently Amended) The capacitance type sensor according to claims 1-~~or~~2,

which further comprises:

a substrate mounting the flexible board thereon; and

~~a supporting member arranged on the first supporting member and supporting~~
disposed on the flexible board and configured to support the detective
member.

4. (New) The capacitance type sensor according to claim 3, wherein a specified space
is defined between the second electrode and the supporting member.

5. (New) The capacitance type sensor according to claim 1, further comprising:
a third electrode disposed on the flexible board;
a reference electrode disposed on the flexible board and having a predetermined
electrical potential; and
a fourth electrode electrically connecting the reference electrode and configured in
a spaced relation to the third electrode, wherein the fourth electrode
contacts with the third electrode by elastic deformation thereof based on the
displacement of the detective member.

6. (New) The capacitance type sensor according to claim 5, wherein the detective
member comprises separate members corresponding to the second electrode and
the fourth electrode, respectively.

7. (New) A capacitance type sensor comprising:

- a substrate;
- a flexible board mounted on the substrate, wherein a first electrode is disposed on a first portion of the flexible board and a second electrode is disposed on a second portion of the flexible board, and the first electrode and the second electrode face each other by folding the flexible board;
- a supporting member disposed on the substrate; and
- a detective member configured to be supported by the supporting member and displaceable by a force applied from outside, wherein displacement of the detective member causes the second electrode to be displaced.

8. (New) The capacitance type sensor according to claim 5, further comprises a resin film covering the first electrode and the second electrode but not covering the central area of the second electrode, wherein an surface of the resin film on the first portion contacts another surface of the resin sheet on the second portion in a state that the flexible board is folded.